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Precise modification of the interface between titanium dioxide and electrolyte of dye-sensitized solar cells with oxides deposited by thermal evaporation of metals and subsequent oxidation

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ABSTRACT

This manuscript reports the modification of the interface between the mesoporous TiO_2 work electrode and electrolyte of dye-sensitized solar cells (DSCs) with oxide layers deposited by the thermal evaporation of metals and subsequent oxidation with UV ozone. Both Al_2O_3 and MgO can be deposited on mesoporous TiO_2 by this method, and their thickness can be precisely controlled. A thin layer of Al_2O_3 or MgO on the TiO_2 work electrode can improve the photovoltaic efficiency. The optimal thicknesses are 14.1 and 4.9 Å for Al_2O_3 and MgO, respectively. The oxide effect has been investigated by the electrochemical impedance spectroscopy, cyclic voltammetry and UV–Vis–NIR absorption spectroscopy. The improvement in the photovoltaic efficiency by an oxide layer is attributed to the upward shift of the conduction band of TiO_2 , the passivation of the TiO_2 surface, and the retardation of the charge recombination through the interface between TiO_2 and electrolyte.

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1. Introduction

Dye-sensitized solar cells (DSCs) have attracted strong attention since their discovery about twenty years ago [1-5]. They are promising to be the next-generation solar cells because of their low fabrication cost and relatively good photon-to-current conversion efficiency (PCE). PCE as high as about 12% had been reported [6]. A DSC is a photoelectrochemical cell which consists of a mesoporous TiO₂ work electrode, a monolayer of dye chemically anchored to TiO₂, an electrolyte comprising redox species, and a catalytic counter electrode. The work principle of DSCs involves the following steps: (1) Light absorption by the dye and formation of excitons; (2) electron injection from the excited dye molecules into TiO_2 ; (3) electron transport along the mesoporous TiO_2 electrode; (4) regeneration of dye by the redox species and transport of the redox species from the work electrode to the counter electrode; (5) regeneration of the redox species at the counter electrode. The interface between the TiO₂ work electrode and the electrolyte plays a key role in the photon-to-electricity conversion [7–9]. Electrons are injected from the excited dye molecules through this interface into TiO₂. But charge recombination may take place through this interface as well. The electrons injected into the mesoporous TiO₂ may pass through this interface and recombine with either the oxidized dye molecules or redox species in the electrolyte. The latter is particularly critical for the photovoltaic performance. The charge recombination lowers both the short-circuit current density (J_{sc}) and open-circuit voltage (V_{oc}) [10–14]. It has been demonstrated that the charge recombination can be retarded by coating a thin layer of oxide like Al₂O₃ or MgO with a wide band gap on the mesoporous TiO₂ work electrode [15–30]. This thin insulating oxide layer serves as an energy barrier, which can suppress both the charge recombination and the electron injection. Thus, it is important to precisely control the thickness of this oxide layer so that the charge recombination can be effectively blocked while it does not significantly affect the electron injection from the dye molecules into TiO₂ [31]. Several methods have been reported to fabricate a thin oxide layer on the mesoporous TiO₂ layer. A wet chemical process like the sol-gel process can convert a metal precursor into metal oxide on TiO₂ [17–20]. But it usually requires a sintering step at 450–500 °C to achieve good quality and is thus not suitable for plastic-based flexible DSCs. In addition, the wet chemical process cannot precisely control the thickness of the oxide layer. The thickness can only be varied at a resolution down to 1 nm. Atomic layer deposition (ALD) can precisely deposit a thin oxide layer through a chemical reaction of a metal precursor and has also been used to coat various oxides on TiO₂ of DSCs [24,26-30]. However, as ALD is a chemical technique, there is always a risk of contaminations from the unused precursors [32,33]. Vapor deposition techniques, including



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magnetron sputtering [25] and chemical vapor deposition [32], were also used to deposit an oxide layer on mesoporous TiO_2 . Special equipments are required for ALD and the vapor deposition.

In this manuscript, we report the deposition of oxides on the mesoporous TiO_2 through the thermal evaporation of metals and subsequent oxidization of the metals into oxides. The thickness of the oxide layer can be precisely controlled by this method. Both Al_2O_3 and MgO were coated on TiO_2 by this method. They can remarkably improve the photovoltaic performance of DSCs.

2. Experimental

2.1. Materials

DSL 18 NR-T (20 nm) and WER2-O (350–450 nm) TiO_2 pastes were purchased from Dyesol. Ti-Nanoxide T (20 nm) TiO_2 paste, ruthenium 535-bis TBA, N719 dye, Surlyn (SX1170-250), which are ionomer films of 25 µm thick, were obtained from Solaronix SA. 1-Methyl-3-propylimidazolium iodide (PMII) (purity > 98%), 1-methyl-3-butylimidazolium tetrafluoroborate (BMIBF₄) (purity > 97%), 4-tier-butylpyridine (TBP) (purity = 99%), anhydrous tert-butanol (purity > 99.5%), chloroplatinic acid hexahydrate (H₂PtCl₆·6H₂O), iodine, acetonitrile, aluminium wire (99%) and magnesium ribbons (99.95%) were supplied by Sigma–Aldrich. Valeronitrile and guanidinium thiocynate were got from Fluka. Titanium tetrachloride (TiCl₄) was obtained from Merck. All chemicals were used as received.

2.2. Fabrication of DSC

DSCs were fabricated through the conventional process [34]. The TiO₂ work electrode consists of a mesoporous TiO₂ layer of 15 µm in thickness (Dyesol DSL 18NR-T of 10) and a scattering TiO₂ layer of 5 µm in thickness (Dyesol WER4-O Reflector paste). Al was deposited onto the TiO₂ work electrode by thermal evaporation in a vacuum of 1.5×10^{-4} Pa with an Edwards Auto 306 thermal evaporator. The thickness was recorded with an Inficon guartz crystal thickness monitor. Al was converted into Al₂O₃ through the oxidation with a Jelight UV Ozone cleaner 42 for 10s. MgO was coated onto the TiO₂ layer through a similar process. The TiO₂ electrodes coated with Al₂O₃ or MgO were then immersed in a 0.5 mM N719 dye solution in a cosolvent of acetonitrile/tertbutanol (volume ratio: 1:1) for 24 h. A cell was made by assembling a dye-impregnated TiO₂ electrode with a counter electrode and sealed with a 25 µm-thick Solaronix polymer melt. The counter electrode was fabricated by the pyrolysis of an ethanol solution of 0.2 M H₂PtCl₆ at 400 °C on a fluorine doped tin oxide (FTO) glass for 15 min. The cells were filled with a liquid electrolyte comprising 0.6 M 1-methyl-3-propylimidazolium iodine, 0.03 M I2, 0.1 M guanidine thiocynate, and 0.5 M 4-tert-butyl pyridine in a cosolvent of acetonitrile/valeronitrile (volume ratio = 85:15).

2.3. Characterization of DSCs

The thicknesses of the TiO₂ layers were determined using a Tencor P-10 Alpha-Step profiler. The absorption spectra were obtained with a Shimadzu UV-1800 UV Spectrophotometer. The X-ray photoelectron spectra (XPS) were acquired using an Axis Ultra DLD X-ray photoelectron spectrometer equipped with an Al Ka X-ray source (1486.6 eV).

The photovoltaic performance of the DSCs was measured with a computer-programmed Keithley 2400 source/meter under AM1.5G Newport's Oriel class A solar simulator (100 mW cm⁻²), which was certified by the JIS C 8912 standard. A circular mask with a diameter of 5.2 mm was placed on each DSC during the tests. Electrochemical impedance spectra (EIS) and cyclic voltammograms (CV) of the cells



Fig. 1. XPS spectra of Al 2p core level of Al₂O₃ coated on mesoporous TiO₂.

were taken with an ECO CHEMIE Autolab (PGSTAT 302N and FRA2). The frequency range of EIS was from 0.1 up to 10^5 Hz, and an ac voltage of 10 mV was superimposed on a dc bias that was set at the V_{oc} of each cell. The CVs were studied in an ionic liquid, 1-methyl-3-butylimidazolium tetrafluoroborate (BMIBF₄), with Ag/Ag⁺ and Pt as the reference and counter electrode, respectively. The work electrodes were bare mesoporous TiO₂ films or mesoporous TiO₂ films coated with Al₂O₃. The scan rate was 50 mV s⁻¹.

3. Results and discussions

3.1. Improvement in the photovoltaic performance of DSCs by Al_2O_3 and MgO

Al can be readily deposited on TiO₂ through thermal evaporation, and its thickness can be well controlled. After the UV ozone treatment, it was studied by XPS (Fig. 1). The Al 2p XPS band appears at 74.1 eV, and no XPS band corresponding to metallic Al can be observed. The XPS indicates the presence of Al₂O₃ on TiO₂ and the complete conversion of Al into Al₂O₃ after the UV ozone treatment [35]. The thickness of the Al₂O₃ layer can be calculated in terms of the thickness of Al recorded by the thickness monitor during the thermal evaporation, the atomic masses of Al (27 g mol⁻¹) and O (16 g mol⁻¹), and the densities of Al (2.7 g cm⁻³) and Al₂O₃ (4.0 g cm⁻³).

The SEM images of a bare mesoporous TiO_2 and a mesoporous TiO_2 coated with a 14.1 Å-thick Al_2O_3 layer $(TiO_2/Al_2O_3 (14.1 Å))$ are presented in Fig. 2. The thin Al_2O_3 layer does not remarkably affect the mesoporous structure of the TiO_2 work electrode. Thus, it may not affect the penetration of dye molecules and the redox species into the pores.

DSCs with Al₂O₃ layers of various thicknesses were fabricated and characterized. The current density (*J*)–voltage (*V*) curves were recorded for DSCs under simulated AM1.5G illumination (Fig. 3). The thickness of the Al₂O₃ layer on the mesoporous TiO₂ electrode was varied from 6.4 up to 25.6 Å. But only the *J*–*V* curve for the DSC with an Al₂O₃ layer of 14.1 Å thick is presented for clarity. *J*–*V* curve of a control DSC without Al₂O₃ is also presented for comparison. The photovoltaic performances, including *J*_{sc}, *V*_{oc}, fill factor (FF) and PCE, are summarized in Table 1. The photovoltaic performances of DSCs, whose *J*–*V* curves are not shown in Fig. 3, are also listed in Table 1. The photovoltaic performance of DSCs is sensitive to the thickness of the Al₂O₃ layer. A thin Al₂O₃ layer increases both the *V*_{oc} and *J*_{sc} values. The photovoltaic performance is quite sensitive to the thickness of the Al₂O₃ layer. The



Fig. 2. SEM images of mesoporous TiO_2 coated (a) without and (b) with a 14.1 Å-thick Al_2O_3 layer.

optimal thickness is 14.1 Å. This optimal thickness is comparable to that by ALD [24,27]. The photovoltaic performances at this optimal Al₂O₃ thickness are: $V_{oc} = 0.78$, $J_{sc} = 13.74 \text{ mA cm}^{-2}$, FF = 0.74, and PCE = 7.96%. PCE is remarkably higher than that (7.44%) of the control DSC without the Al₂O₃ layer. In addition, the maximum output power density of the DSC under simulated AM1.5G illumination increased from 7.44 mW cm⁻² to 7.96 mW cm⁻² after the modifi-



Fig. 3. J-V curves of DSCs with the TiO₂ work electrode without (solid curves) and with (dash curves) a 14.1 Å-thick Al₂O₃ layer. The devices were tested under AM1.5 G illumination and in dark.

Photovoltaic performances of DSCs with Al₂O₃ layers of various thicknesses.

Thickness of Al_2O_3 (Å)	$V_{\rm oc}~({ m V})$	$J_{\rm sc}$ (mA cm ⁻²)	FF	PCE (%)
0	0.76	12.89	0.76	7.44
6.4	0.78	13.12	0.75	7.70
10.2	0.79	13.25	0.74	7.76
11.5	0.79	13.46	0.74	7.82
12.8	0.79	13.48	0.74	7.87
14.1	0.78	13.74	0.74	7.96
15.4	0.78	13.60	0.75	7.94
19.2	0.76	13.12	0.76	7.56
25.6	0.75	12.92	0.76	7.39



Fig. 4. J-V curves of DSCs with the TiO₂ work electrode without (solid curves) and with (dash curves) a 4.9 Å-thick MgO layer. These devices were tested under AM1.5G illumination and in dark.

cation of the TiO₂ with a 14.1 Å-thick Al₂O₃ layer. Both the V_{oc} and J_{sc} values decrease with the further increase in the thickness of the Al₂O₃ layer. V_{oc}, J_{sc}, PCE and the maximum output power density decrease to 0.75 V, 12.92 mA cm⁻², 7.39% and 7.39 mW cm⁻², respectively, when the Al₂O₃ layer is 25.6 Å thick.

Depositing an insulating oxide layer on the TiO_2 work electrode has been reported for DSCs in literature. It is somewhat strange that relative poor PCEs ranging from 3.7% to 5.75% were usually reported for the control DSCs without the insulating oxide layer. Although remarkable improvement in the PCE was observed after the deposition of an insulating oxide layer, the PCEs of the modified DSCs were still in the range from 5% to 6.5%. It is important to improve the performance of high-performance control devices. In this research work, the deposition of an Al_2O_3 layer can improve the PCE from 7.44% to 7.96%. The PCE of the modified DSCs is higher than most of the PCE values reported for modified DSCs in literature.

Besides Al_2O_3 , MgO was also coated on the mesoporous TiO_2 electrodes through the thermal deposition of Mg and subsequent oxidation by UV ozone. The photovoltaic *J*–*V* curves of DSCs with MgO are presented in Fig. 4, and the photovoltaic performances are summarized in Table 2. These results indicate that the optimal thickness of the MgO layer is 4.9 Å. The photovoltaic performance

Table 2			
Photovoltaic	performances of DSCs	with MgO layers o	f various thicknesses

Thickness of MgO (Å)	$V_{\rm oc} ({ m V})$	$J_{\rm sc}$ (mA cm ⁻²)	FF	PCE (%)
0	0.76	12.89	0.76	7.44
4.1	0.77	13.14	0.76	7.76
4.9	0.78	12.95	0.77	7.82
5.7	0.76	13.19	0.76	7.63
8.1	0.78	13.00	0.77	7.77
12.2	0.78	12.78	0.77	7.66



Fig. 5. Cyclic-voltammograms of TiO_2 (solid line) and TiO_2 coated with a 14.1 Å-thick Al_2O_3 layer (dashed line).

at the optimal thickness is: $V_{oc} = 0.78$, $J_{sc} = 12.95 \text{ mA cm}^{-2}$, FF = 0.77, and PCE = 7.82%. Accordingly, the maximum output power density increases from 7.44 mW cm $^{-2}$ to 7.82 mW cm $^{-2}$. The photovoltaic performance slightly decreases when the MgO layer becomes thicker.

3.2. Mechanism for Al₂O₃-induced improvement in photovoltaic performance of DSCs

The oxide effect on the photovoltaic performance of DSCs was investigated by CV, EIS and UV-Vis-NIR absorption spectroscopy. TiO_2 and TiO_2/Al_2O_3 were used as the work electrode for CV (Fig. 5). In principle, for a junction between an n-type semiconductor like TiO₂ and electrolyte, electron injection will commence once the quasi-Fermi level of the electrolyte reaches the lowest edge of the conduction band of the semiconductor. The CV can be affected by the presence of coordinatively unsaturated Ti species on the surface of TiO₂ which causes the existence of electronic levels at energies below the conduction band edge [36-38]. These surface states give rise to the graduate onset capacitance current as observed on the CV of the bare mesoporous TiO₂. The current increases much more slowly for the TiO₂/Al₂O₃ electrode than that for the bare TiO₂ electrode during the potential scan from 0.5 to -1.5 V versus Ag/Ag⁺. This indicates the surface passivation of TiO₂ by Al₂O₃ [39]. The onset anodic current shifts to a more negative potential for the TiO_2/Al_2O_3 electrode, in comparison to the bare TiO_2 electrode. This indicates that Al₂O₃ shifts the conduction band of TiO₂ upward [23,38]. The oxide-induced shift in the conduction band of TiO₂ was also observed by other techniques [39,40]. The passivation of the TiO₂ surface can reduce the dark current, and the upward shift of the conduction band contributes to the increase in V_{oc} of the DSCs with an Al_2O_3 layer.

The oxide effect is also studied by EIS. Nyquist plots of DSCs with a bare mesoporous TiO_2 and a mesoporous TiO_2/Al_2O_3 work electrodes were extracted from the EIS data (Fig. 6). There are usually two or three arcs or semicircles in the Nyquist plot of a DSC. The first semicircle at the high frequency range is attributed to the charge transfer at the counter electrode [41–43]. The second semicircle at the middle frequency range is due to the charge transfer at the TiO_2 /electrolyte interface and the electron transport through the mesoporous TiO_2 work electrode. The first process for the charge transfer through the TiO_2 /electrolyte interface is the main contribution for the impedance in this frequency range [44,45]. The third arc in the low-frequency range originates from the Nernstian diffusion of the redox species through the electrolyte. The big semicircles in



Fig. 6. Nyquist plots of DSCs with a 0, 11.5, 14.1, 19.2 and 25.6 Å-thick Al_2O_3 layer coated on the TiO₂ work electrode. The inset is the equivalent circuit.

the Nyquist plots in Fig. 6 correspond to the charge transfer at the TiO_2 /electrolyte interface and the electron transport through the mesoporous TiO_2 work electrode [46].

The resistances (*R*) corresponding to the semicircles in the middle frequency range were calculated by fitting the Nyquist plots. They were plotted versus the thickness of the Al₂O₃ layer (Fig. 7). In *R* almost linearly increases with the increasing Al₂O₃ thickness (*t*), that is, $R \alpha e^{\beta t}$, where β is constant. This relationship is consistent with the charge tunneling mechanism. Thus, the insulating Al₂O₃ layer can reduce the charge recombination.

The UV–Vis absorption spectra of TiO₂ and TiO₂/Al₂O₃ impregnated with the dye molecules were measured to understand possible effect of Al₂O₃ on the dye impregnation (Fig. 8). The two absorption spectra are almost the same. Hence, coating of Al₂O₃ does not affect the dye loading on the work electrode, because the dye molecules can also anchor on the surface of Al₂O₃. This confirms that the Al₂O₃-induced increase in J_{sc} is mainly due to the retardation of the charge recombination.



Fig. 7. Variation of the resistance corresponding to the second arc of ac impedance spectrum with the thickness of the Al₂O₃ layer coated on the mesoporous TiO₂ work electrode of DSCs.



Fig. 8. UV-Vis absorption spectra of dye-impregnated TiO₂ without and with a 14.1 Å-thick Al₂O₃ layer coated on the TiO₂ layer.

4. Conclusions

In conclusion, metal oxides with precise thickness can be coated on mesoporous TiO₂ through the thermal evaporation of the corresponding metals and subsequent oxidation with UV-ozone. Both Al₂O₃ and MgO are coated on the mesoporous TiO₂ electrodes by this method. An oxide layer can remarkably improve the photovoltaic performance of DSCs. The photovoltaic performance is sensitive to the thickness of the oxide layer. The optimal thicknesses are 14.1 and 4.9 Å for Al₂O₃ and MgO, respectively. The oxide effect on the photovoltaic performance of DSCs is attributed to the passivation of the TiO₂ surface, upward shift of the conduction band of TiO₂, and retardation of the charge combination.

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